IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Hideki KUWAJIMA et al.

Serial No. NEW : Attn: APPLICATION BRANCH

Filed December 3, 2003 : Attorney Docket No. 2003 1661A

THIN FILM PIEZOELECTRIC ELEMENT, ITS MANUFACTURING METHOD, AND ACTUATOR USING THE SAME

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

1a. [X] This Information Disclosure Statement is submitted:

within three months of the filing date (or of entry into the National Stage) of the above-entitled application, or

before the mailing date of the first Office Action on the merits,

and thus no certification and/or fee is required.

1b. [] This Information Disclosure Statement is submitted

after the events of above paragraph 1a and prior to the mailing date of a final Office Action or a Notice of Allowance or an action which otherwise closes prosecution in the application, and thus:

- (1) [] the certification of paragraph 2 below is provided, or
- (2) [] the fee of \$180.00 specified in 37 CFR 1.17(p) is enclosed.
- 1c. [] This Information Disclosure Statement is submitted:

after the mailing date of a final Office Action or Notice of Allowance or action which otherwise closes prosecution in the application, and prior to payment of the issue fee, and thus:

the certification of paragraph 2 below is provided, and

the fee of \$180.00 specified in 37 CFR 1.17(p) is enclosed.

- 2. It is hereby certified
 - a. [] that each item of information contained in this Information Disclosure

 Statement was first cited in any communication from a foreign patent office in a

 counterpart foreign application not more than three months prior to the filing of
 the Statement, or
 - b. [] that no item of information contained in the Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application and, to the knowledge of the person signing the certification after making reasonable inquiry, was known to any individual designated in §1.56(c) more than three months prior to the filing of the Statement.
- 3. [] Consideration of the following list of additional information (including any copending or abandoned U.S. application, prior uses and/or sales, etc.) is requested.

- 4. For each non-English language reference listed on the attached form PTO-1449, reference is made to:
 a. [X] a full or partial English language translation submitted herewith,
 b. [] a foreign patent office search report (in the English language) submitted herewith,
 c. [X] the concise explanation contained in the specification of the present application at pages 1, 2 and 5,
 - d. [X] the concise explanation set forth in the attached English language abstract,
 - e. [] the concise explanation set forth below or on a separate sheet attached to the reference:
- 5. [] A foreign patent office search report citing one or more of the references is enclosed.

Respectfully submitted,

Hideki KUWAJIMA et al.

By Charles R. Watts

Registration No. 33,142

Attorney for Applicants

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Sheet 1 of 1									
FORM PTO 1449 (modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary) Date Submitted to PTO: December 3, 2003				ATTY DOCKET NO. SERIAL NEW					
				APPLICANT Hideki KUWAJIMA et al.					
				FILING DATE December 3, 2003			GROUP		
U.S. PATENT DOCUMENTS									
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FOREIGN PATENT DOCUMENTS									
		DOCUMENT NUMBER	DATE	COUNTRY	СІ	LASS	SUBCLASS	TRANSLA YES	ATION NO
	AJ	2002-134807	5/2002	JP				Abstract	
	AK	8-88419	4/1996	JP				Abstract	
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OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)									
	AO	Y. UEMATSU, "SWITCHING TO SUPER-HIGH TPI AND PIGGY-BACK ACTUATOR", IDEMA Japan News, No 32, pp. 4-7, International Disk Drive Association (partial English translation)							
	АР								
	AQ								
EXAMINER				DATE CONSIDERED					